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Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	10/733,352
		Filing Date	December 12, 2003
		First Named Inventor	Shunpei YAMAZAKI et al.
		Group Art Unit	2812
		Examiner Name	S. Isaac
Sheet 1 of 4	Attorney Docket Number	0756-7227	

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
SDI		2001/0034088		Nakamura et al.	10/25/2001	
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Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ³
SDI		K.S. JONES et al., <i>Boron Diffusion upon Annealing of Laser Thermal Processed Silicon</i> , Ion Implantation Technology 2000, IEEE, 2000, Pages 111-114	
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Examiner Signature	<i>Stanetta Baac</i>	Date Considered	12/26/05
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Examiner Signature	<i>Shanetta L. Gage</i>	Date Considered	12/26/05
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